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(Use several sheets if necessary)

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8075-1025

Application No.: 20/5644/2003
NEW NATIONAL PHASE

Applicant:

Applicant: Tomohiko Saito NAGAETAL 11 JAN 2006

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Fukuda T. FUKUDA et al., Crystal growth of oxide and fluoride materials for optical, piezoelectric and other applications, Journal of Materials Science, Materials in Electronics, 1999, Vol. 10, pages 571 to 580

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DATE CONSIDERED

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